

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Thomas Hecht et al.

Serial No.: Unknown  
(Priority Application No. DE 102 45 537.6)  
(International Application No. PCT/DE03/03188)

**10/529412**  
**JC17 Rec'd PCT/PTO 29 MAR 2005**

Filed: Herewith  
(Priority Date: September 30, 2002)  
(International Filing Date: September 24, 2003)

Docket No.: I433.153.101/13.555

Title: METHOD AND PROCESS REACTOR FOR SEQUENTIAL GAS PHASE  
DEPOSITION BY MEANS OF A PROCESS CHAMBER AND AN  
AUXILIARY CHAMBER (As Amended)

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**INFORMATION DISCLOSURE STATEMENT**

Mail Stop PCT  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56, it is respectfully requested that this Information Disclosure Statement be entered and the documents listed on attached form 1449 be considered by the Examiner and made of record. Any required copies of patents, publications or other documents are enclosed for the Examiner's review. Pursuant to the provisions of M.P.E.P. 609, Applicants further request a copy of the 1449 form, marked as being considered and initialed by the Examiner, be returned with the next Official Communication.

Since this Information Disclosure Statement is being submitted within three months of filing national application; or date of entry of national application; or before the mailing date of the first Office Action on the merits, a fee has not been enclosed. However, if such fee is required, the Patent Office is hereby authorized to charge Deposit Account No. 500471 for fees as set forth under 37 C.F.R. 1.17(p).

**Information Disclosure Statement**

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Applicants respectfully request consideration of these references during prosecution of the above-identified matter. The Examiner is invited to contact the Applicants' representative at the below-listed telephone number if there are any questions regarding this Communication or the tendered references.

Respectfully submitted,

Thomas Hecht et al.,

By their attorneys,

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Dated: 3/29/05

PPK:cmj

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**CERTIFICATE UNDER 37 C.F.R. 1.10:**

"Express Mail" mailing label number: EV525782580US

Date of Deposit: March 29, 2005

The undersigned hereby certifies that this paper or papers, as described herein, are being deposited in the United States Postal Service "Express Mail Post Office to Addressee" service under 37 C.F.R. 1.10 on the date indicated above and is addressed to: Mail Stop PCT, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

By

Name: Vanessa Carels

FORM PTO-1449	Docket No.: 1433.153.101/13.555	Serial No.: Unknown Priority Appl. No. DE 102 45 537.6 Int'l Appl. No. PCT/DE03/03188 <b>10/529412</b>
	LIST OF PATENTS AND PUBLICATIONS FOR APPLICANT'S INFORMATION DISCLOSURE STATEMENT	
Applicant: Thomas Hecht et al.		
Filing Date: Herewith Priority Date: Sept. 30, 2002 Int'l Filing Date: Sept. 24, 2003		Group Art:

U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Date	Name	Class	Sub Class	Filing Date If Appropriate
	5,357,996	10/1994	Ioannides et al.			
	5,916,365	6/1999	Sherman			

FOREIGN PATENT DOCUMENTS

	Document No.	Date	Country	Class	Sub Class	Translated Yes No
	0 095 369	11/1983	EP			Yes
	1 321 640	6/1973	GB			Yes
	52016012	2/1977	JP			Yes (Abstract Only)
	54113511	9/1979	JP			Yes (Abstract Only)
	2000195803	7/2000	JP			Yes (Abstract Only)

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)


EXAMINER:

DATE CONSIDERED:

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.